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STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10707918
Filing Date	2004-01-23
First Named Inventor	Siegel, Scott H.
Art Unit	2624
Examiner Name	Chu, Randolph I
Attorney Docket Number	CT 0123

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Electronic Version v18

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Title of Invention

Radiography Image Management System

Application Number :

Confirmation Number:

First Named Applicant: Scott Siegel

Attorney Docket Number: CT 0123

Art Unit:

Examiner:

Search string: (6633674 or 6178225 or 20020082850).pn

US Patent Documents

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init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
/S.K./	1	6633674	2003-10-14	Barnes et al	B1	382	232
/S.K./	2	6178225	2001-01-23	Zur et al	B1	378	98.2

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/S.K./	2	6711297	B1	2004-03-23	Chang et al	Col 1, line 34 to col 2, line 27; col 2, lines 57-67; col 3, lines 1-9; col 3, line 62 to col 4, line 31; col 5, line 1 to col 6, line 16; col 13, line 55 to col 14, line 48.	
/S.K./	3	6633684	B1	2003-10-14	James	Background document	
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